

# SIEMENS

PATENT  
Attorney Docket No. 2003P08356WOUS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventor:	S. Haaks et al.	)	Group Art Unit:	2123
		)		
Serial No.:	10/559,865	)	Confirm. No.:	7446
		)		
Filed:	12/07/2005	)	Examiner:	LAUGHLIN, Nathan L.
Title:	METHOD AND DEVICE FOR DETERMINING THE CAUSES OF FAILURES IN INDUSTRIAL PROCESSES			

Mail Stop AF  
**Commissioner for Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

RESPONSE UNDER 37 CFR 1.116

Applicants submit the following amendments and remarks in response to the Office Communication of 12 March 2009. Entry of this amendment is respectfully requested in order to place the application in condition for allowance, or in the alternative, to place the claims into better form for consideration upon appeal.

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